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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/635,006	08/06/2003	Koichi Fukuda	OKI.561	7606	
20987	7590 12/23/2004		EXAM	EXAMINER	
	E FRANCOS, & WHIT	HU, SHO	HU, SHOUXIANG		
ONE FREEDO	OM SQUARE OOM DRIVE SUITE 1260	) .	ART UNIT	PAPER NUMBER	
RESTON, VA			2811		
			DATE MAIL ED: 12/22/200	4	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/635,006	FUKUDA, KOICHI	FUKUDA, KOICHI			
Office Action Summary	Examiner	Art Unit				
	Shouxiang Hu	2811	A			
The MAILING DATE of this communication ap Period for Reply	pears on the cover sheet wi	th the correspondence addre	ess			
A SHORTENED STATUTORY PERIOD FOR REPL THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a rep. If NO period for reply specified above, the maximum statutory period.  - Failure to reply within the set or extended period for reply will, by statut Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, however, may a really within the statutory minimum of thirt will apply and will expire SIX (6) MON e, cause the application to become AB	eply be timely filed  y (30) days will be considered timely.  THS from the mailing date of this commandered (35 U.S.C. § 133).	nunication.			
Status			•			
1)⊠ Responsive to communication(s) filed on <u>13 (</u>	October 2004.					
2a) ☐ This action is <b>FINAL</b> . 2b) ☑ Thi	s action is non-final.					
. —	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims						
4) ⊠ Claim(s) 1-20 is/are pending in the application 4a) Of the above claim(s) is/are withdra 5) ☐ Claim(s) is/are allowed. 6) ⊠ Claim(s) 1-20 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or	awn from consideration.					
Application Papers						
9) The specification is objected to by the Examin  10) The drawing(s) filed on is/are: a) accomposed and applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Examin	cepted or b) objected to drawing(s) be held in abeyant ction is required if the drawing(	ce. See 37 CFR 1.85(a). (s) is objected to. See 37 CFR	, ,			
Priority under 35 U.S.C. § 119						
a) All b) Some * c) None of:  1. Certified copies of the priority documen  2. Certified copies of the priority documen  3. Copies of the certified copies of the priority documen  application from the International Burea  * See the attached detailed Office action for a list	ts have been received. ts have been received in A prity documents have been nu (PCT Rule 17.2(a)).	pplication No received in this National Sta	age			
Attachment(s)  1) Notice of References Cited (PTO-892)  2) Notice of Draftsperson's Patent Drawing Review (PTO-948)  3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08 Paper No(s)/Mail Date 5/27/04, 11/19/03	Paper No(s	Summary (PTO-413) s)/Mail Date nformal Patent Application (PTO-15	52)			

### **DETAILED ACTION**

#### Election/Restrictions

1. Applicant's election with traverse of Species I in the reply filed on October 13, 2004 is acknowledged. The traversal is on the ground(s) that claims 1-3, 5, 6, 13-15, 17 and 18 are generic to each of Species I-III. This is not found persuasive as explained below:

The Species I, II and III as identified in the previous office action are obviously mutually distinctive from each other. Although some of the pending claims may be readable on each of the species, it does not necessarily mean that these claims are each generic to the invention defined by each of the pending claims. For example, claim 1 defines raised S/D electrodes made of polysilicon, which may not necessarily readable on the invention defined in claim 7 which recites raised S/D electrodes made of silicide.

Nevertheless, upon the allowance of any of the pending independent claims (1, 7 and 13, applicant will be entitled to consideration of claims to additional species which are written in dependent form or otherwise include all the limitations of any of the allowed independent claims.

The requirement is still deemed proper and is therefore made FINAL.

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2. Claims 1-20 are objected to because of the following informalities and/or defects:

Claims 1, 7 and 13 each recites the subject matters that the recited thin silicon layer is surrounded by the recited isolation layer. However, according to the instant disclosure, especially the drawings, the thin silicon layer (33) is only sided, instead of being surrounded, by the recited isolation layer (37), as the term of "surround" may mean: to cover from all the directions.

In claims 2, 8 and 14, the term of "surrounds" appears to be inappropriate, as the sidewall does not fully surround the gate electrode.

Claims 5, 11 and 17 each recite the subject matters that the thin silicon layer is about 20 to 80 percent of a total thickness of it and the polysilicon or the silicide layer, which does not fully reflect what is disclosed in the specification (see page 7, lines 4-7), in which the total thickness includes each of the polysilicon layer, the silicide layer and the thin silicon layer.

In claims 6, 12 and 18, the term of "about less than" should read as: --less than about--.

Regarding claims 8 and 20, it is noted that only a portion of the recited silicide or conductive layer is formed on the gate electrode.

Appropriate correction is required.

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## Claim Rejections - 35 USC § 102

3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 4. Claims 1-5, 7-11, 13-17, 19 and 20, as being best understood in view of the claim objections above, are rejected under 35 U.S.C. 102(b) as being anticipated by Wakahara (JP 2000-183355; 06/30/2000; of record).

Wakahara discloses an SOI-MOS transistor (Fig. 11) which is naturally capable of functioning as a full depletion type as the SOI layer (3) therein can be as thin as 50 nm (see Paragraph 0020), comprising: a substrate (1); a BOX layer (2); the SOI layer (3) including a channel region and a source/drain region (9); an (element) isolation layer (4) siding the SOI layer on both of the two sides; a gate insulation layer (5); a gate electrode (6); a sidewall (11); and, a high mobility conductive layer including a silicon layer (13b) and/or a silicide layer (15), wherein the high mobility conductive layer is on, or extends to, the source/drain region, the gate electrode (6), the isolation layer (4) and the sidewall (11). It is noted that the silicon layer (13b) therein is naturally a polysilicon since the nature of the deposition in which at least a portion of the silicon layer (13b) is deposited on the isolation layer (4).

Regarding claims 5, 11 and 17, it is noted that thin silicon layer (3) in Wakahara is naturally about 20 to 80 percent of a total thickness of it, the polysilicon layer (13b) and the silicide layer (15), as shown in Figs. 10 and 11).

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## Claim Rejections - 35 USC § 103

5. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 6. Claims 6, 12 and 18, as being best understood in view of the claim objections above, are rejected under 35 U.S.C. 103(a) as being unpatentable over Wakahara in view of Cheng (US 2002/0171107).

The disclosure of Wakahara is discussed as applied to claims 1-5, 7-11, 13-17, 19 and 20 above.

Although Wakahara does not expressly disclose that the thickness of the SOI layer (thin silicon layer) can be as thin as about 30 nm or less, it is art known that such thickness is well within the commonly recognized range for fully depletion type SOI layer for achieving desired good channel performance, as readily evidenced in the prior art such as Cheng (see Paragraph 0014).

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to SOI device of Wakahara with the thickness of the SOI layer being less than about 30 nm, per the teachings of Cheng, so that a full depletion SOI-MOS transistor with desired good channel performance would be obtained.

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Conclusion

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7. The prior art made of record and not relied upon is considered pertinent to

applicant's disclosure. References B-F are cited as being related to a raised S/D

structure.

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Shouxiang Hu whose telephone number is 571-272-

1654. The examiner can normally be reached on Monday through Thursday, 7:30 AM

to 6:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Eddie C. Lee can be reached on 571-272-1732. The fax phone number for

the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the

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Business Center (EBC) at 866-217-9197 (toll-free).

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December 20, 2004\_

SHOUXIANG HU